

# Matlab minority carriers documentation

## What does the app do?

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The analysis of time-resolved photoluminescence lifetime data as a function of temperature is needed in order to understand the dominant recombination mechanisms of a material. This will give evidence of device performance, and can suggest whether material growth quality can improve. Here, a MATLAB application is created which allows for further analysis of lifetime results and its subroutines are discussed. The format of the documentation will be closer to article-style, to allow for reference in future manuscript drafting. A walkthrough of the MATLAB application will be provided in a powerpoint format to understand the proper buttons that need to be pushed for data analysis.

**Usage:** The documentation will allow for quick and easy reference for understanding the MATLAB app, and will provide for discussion of recombination mechanisms and formulas used to model the lifetime.

### I. INTRODUCTION: MOTIVATION

The mechanisms that are attributed to the minority carrier lifetime contain multiple components. Understanding the constituents that make up the lifetime character of a sample provides evidence of device performance. For background limited performance (BLIP), the photon generation rate per unit area needs to be greater than the thermal generation rate per unit area,[1] or

$$\eta_a \Phi_B > \frac{n_{th} t}{\tau}, \quad (1)$$

where  $\eta_a$  is the absorption efficiency,  $\Phi_B$  the background flux,  $n_{th}$ ,  $t$ , and  $\tau$  are the density of thermal carriers, thickness of the material and lifetime of the carriers, respectively. For best performance, the lifetime needs to be at a maximum. The minority carrier lifetime will be considered here because the material system of interest are direct band gap materials.

### II. DATA ANALYSIS

The minority carrier lifetime can be characterized by its recombination mechanisms,

$$\frac{1}{\tau_{tot}} = \frac{1}{\tau_{SRH}} + \frac{1}{\gamma \tau_{rad}} + \frac{1}{\tau_{Auger}}, \quad (2)$$

where  $\tau_{SRH}$  is the Shockley-Read-Hall (SRH) lifetime,  $\gamma$  the photon recycling factor,  $\tau_{rad}$  the radiative lifetime and  $\tau_{Auger}$  is the Auger lifetime. The lifetime components are added as recombination rates in order to calculate the total lifetime, which is why the reciprocals are added in Eq. 2.

### A. Shockley-Read-Hall Recombination

The recombination of photoexcited carriers with defects in a material is the SRH recombination mechanism. This is observed because there are defect levels,  $E_t$  that occur within the forbidden band gap of a material. The lifetime due to SRH recombination is[2, 3]

$$\tau_{SRH} = \frac{\tau_{p0}(n_0 + n_1) + \tau_{n0}(p_0 + p_1)}{n_0 + p_0}. \quad (3)$$

In the case of an n-type sample, and approximating with Boltzmann statistics and parabolic bands[4] we can define the quantities in Eq. 3 by

$$n_0 - p_0 = D \quad (4)$$

$$n_0 p_0 = n_i^2 = N_c N_v \exp(-E_g/kT) \quad (5)$$

$$\Rightarrow n_0 = \frac{1}{2} \left( \sqrt{D^2 + 4n_i^2} + D \right) \quad (6)$$

$$n_1 = N_c \exp(E_t - E_c)/kT \quad (7)$$

$$N_c = \frac{1}{4} \left( \frac{2m_e^* kT}{\pi \hbar^2} \right)^{3/2} \quad (8)$$

$$\tau_{p0} = \frac{1}{\sigma_p v_{th} N_t} \quad (9)$$

$$v_{th} = \sqrt{\frac{8kT}{\pi m^*}} \quad (10)$$

where  $D$  is the doping concentration,  $n_0$  is the concentration of electrons in thermal equilibrium,  $n_1$  is the density of electrons for the case of the fermi level falling at the trap level  $E_t$ ,  $N_c$  is the effective electron density of states,  $\tau_{p0}$  is the lifetime for holes injected in a p-type sample, and  $v_{th}$  is the thermal velocity. The quantities  $\tau_{n0}$ ,  $p_0$ ,  $p_1$ , etc. can be found by similar equations and through the relation  $p_0 = n_i^2/n_0$ . When analyzing the total lifetime, the doping  $D$ , trap level  $E_t$ , and the product  $\sigma N_t$  are fit parameters to the data. In the case of degenerate materials, such as highly doped materials, metals or

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materials with a negative band gap, Fermi-Dirac statistics will need to be considered. This then causes the approximation of the right hand side of Eq. 5 to become invalid.

## B. Radiative Recombination

Photoexcited carriers in the conduction band recombine with vacancies in the valence band and release the excess energy in the form of a photon, we can model the radiative lifetime through the thermal generation rate introduced by Van Roosbroeck and Shockley,[5]

$$G_R = \frac{8\pi}{h^3 c^2} \int_0^\infty \frac{\epsilon(E) \alpha(E) E^2 dE}{\exp(E/kT) - 1}, \quad (11)$$

where  $\epsilon$  is the relative dielectric constant which is typically approximated by the static dielectric constant taken at energies below the fundamental absorption edge,  $\epsilon_\infty$ ,  $\alpha$  is the absorption coefficient, and  $E$  is the photon energy. The integral can be integrated numerically with indirect experiments[6] of the absorption coefficient, such as transmission. Another method is through simulation[7, 8] by using a 14 band **k.p.** theory software.[9] Here, we will compute the integral by giving an approximate analytic form of the absorption coefficient, where the same method was used on analyzing the radiative lifetime on Ge[10] and HgCdTe[11–13] material systems. The analytic form of the absorption coefficient is

$$\alpha_{direct} = \frac{2^{3/2}}{3\epsilon_\infty^{1/2}} \frac{m_0 e^2}{\hbar^2} \left[ \frac{m_e^* m_h^*}{m_0(m_e^* + m_h^*)} \right]^{3/2} \left( 1 + \frac{m_0}{m_e^*} + \frac{m_0}{m_h^*} \right) \times \left( \frac{E - E_g}{m_0 c^2} \right)^{1/2}, \quad (12)$$

where  $m_0$  is the free electron rest mass,  $m_e^*$  is the conduction electron effective mass,  $m_h^*$  is the valence heavy hole effective mass, and  $E_g$  is the material band gap. Inserting this in Eq. 11, we have

$$G_R = n_i^2 5.8 \times 10^{-13} \epsilon_\infty^{1/2} \left( \frac{m_0}{m_e^* + m_h^*} \right)^{1/2} \left( 1 + \frac{m_0}{m_e^*} + \frac{m_0}{m_h^*} \right) \times \left( \frac{300}{T} \right)^{3/2} (E_g^2 + 3kTE_g + 3.75(kT)^2). \quad (13)$$

The effective masses used for the group III-V material systems will be the effective masses of the major constituents. For example, for an InAs<sub>0.91</sub>Sb<sub>0.09</sub> alloy, the effective mass[14] and static dielectric constant of bulk InAs[15] will be used.

The radiative generation rate developed in Eq.13 is valid for the internal radiative generation and in a doped sample the internal radiative lifetime becomes

$$\tau_{rad} = \frac{n_i^2}{G_R(n_0 + p_0)}, \quad (14)$$

but when analyzing the minority carrier lifetime from external measurements such as Time-resolved photoluminescence (TRPL) the simulations tend to underestimate the radiative lifetime. What needs to be considered is the photon recycling factor; this is where the emitted photon is reabsorbed in the active region of a material

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- [1] M. A. Kinch, J. Electron. Mater. **29**, 809 (2000).
  - [2] W. Shockley and W. T. Read, Phys. Rev. **87**, 835 (1952).
  - [3] R. N. Hall, Phys. Rev. **87**, 387 (1952).
  - [4] J. S. Blakemore, *Semiconductor Statistics* (Pergamon Press, London, 1962).
  - [5] W. V. Roosbroeck and W. Shockley, Phys. Rev. **94**, 1558 (1954).
  - [6] L. Höglund, D. Z. Ting, A. Khoshakhlagh, A. Soibel, C. J. Hill, A. Fisher, S. Keo, and S. D. Gunapala, Appl. Phys. Lett. **103**, 221908 (2013).
  - [7] B. V. Olson, E. A. Shaner, J. K. Kim, J. F. Klem, S. D. Hawkins, and M. E. Flatté, Appl. Phys. Lett. **103**, 052106 (2013).
  - [8] B. V. Olson, E. A. Kadlec, J. F. Klem, S. D. Hawkins, E. A. Shaner, and M. E. Flatté, Phys. Rev. Appl. **3**, 044010 (2015).
  - [9] W. H. Lau, J. T. Olesberg, and M. E. Flatté, e-print arXiv:cond-mat0406201.
  - [10] R. N. Hall, Proc. IEE B **106**, 923 (1959).
  - [11] M. A. Kinch, M. J. Brau, and A. Simmons, J. Appl. Phys. **44**, 1649 (1973).
  - [12] S. E. Schacham and E. Finkam, J. Appl. Phys. **17**, 2001 (1985).
  - [13] V. C. Lopes, A. J. Syllaios, and M. C. Chen, Semicond. Sci. Technol. **8**, 824 (1993).
  - [14] I. Vurgaftman, J. R. Meyer, and L. R. Ram-Mohan, J. Appl. Phys. **89**, 5815 (2001).
  - [15] S. Zollner, P. P. Paradis, F. Abadizaman, and N. S. Samarasingha, J. Vac. Sci. Technol. B **37**, 012904 (2019).